FORM PTO-1449  U.S. Department of Commer Patent and Trademark Offi			merce Office	Atty. Doc P26894	cket No.		Application No. 10/525,724		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant Yoshiaki SUZUK et al.					
(Use several sheets if necessary)				Filing Da February		Group 1794			
		U.S. PATENT D	OCUMI	ENTS					
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		FOREIGN PATEN	T DOC	IMENTS					
	POREIGNIFATENTIDO			UMENTS		TRANSL		ATION	
	DOCUMENT NUMBER	DATE	DATE COUNTRY		CLASS	SUBCLASS	YES	NO	
		NTS (Including Au							
/RZ/	Kobayashi et al., "Surface Modification of silicone sheets and tubes using plasma-based ion implantation" Surface & Coatings Technology 201 (2007) 8039-8042.								
EXAMINER	/Ramsey Zacharia/			TE CONSID		/29/2009			
*EXAMINER: Initial Include copy of this fo	if citation considered, whether or not citati	on is in conformance	with MP	EP 609; draw	line through citat	ion if not in confor	mance and not	considered	